

<b>Notice of References Cited</b>	Application/Control No. 10/808,858		Applicant(s)/Patent Under Reexamination NISBET ET AL.	
	Examiner MICHAEL L. SHIPPEN		Art Unit 1621	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,004,844	04-1991	Van Leeuwen et al.	568/880
	B	US-5,015,787	05-1991	Van Peppen, Jan F.	568/835
	C	US-6,015,927	01-2000	Kiel, Wolfgang	568/362
	D	US-6,215,030	04-2001	Morikawa et al.	568/814
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 06032747 A	02-1994	Japan	NAKAYAMA et al.	C07C 15/02
	O	WO 200226680 A1	04-2002	World Intellect	CHI et al.	C07C 37/08
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.